



Attorney Docket No. 0553-0185.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Mitsunori SAKAMA et al

Serial No.: 10/669,284

Filed: September 24, 2003

Art Unit: 2826

Examiner: Johannes P. Mondt

For: SEMICONDUCTOR DEVICE AND A
METHOD OF MANUFACTURING THE SAME

)
) I hereby certify that this correspondence
) is being deposited with the United States
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)
) Shannon Wallace
)

)
)
) Date: October 3, 2005

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. Pursuant to 37 CFR §1.98(a)(2)(i) copies of cited US patent and US patent application publications are not submitted herewith. Copies of foreign patent documents and non-patent literature documents are enclosed herewith for the Examiner's consideration.

No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

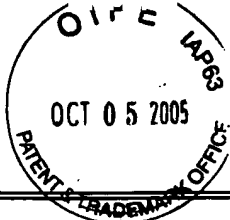
A first office action, notice of allowance or issue fee notification has been received in this case, so a check in the amount of \$180.00 is enclosed. If any additional fee is required, please charge Deposit Account No. 50/1039.

Respectfully submitted,



Mark J. Murphy
Registration No.: 34,225

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LIST OF PUBLICATIONS CITED BY APPLICANT	<u>Atty. Docket No.</u> 0553-0185.01	<u>Serial No.</u> 10/669,284
	<u>Applicant</u> Mitsunori SAKAMA et al	
	<u>Filing Date</u> September 24, 2003	<u>Group</u> 2826

US PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	3,765,935	10/16/73	Rand et al	117	201	08/10/71
	5,274,602	12/28/93	Glenn	365	239	10/22/91
	5,972,437	10/26/99	Ohori et al	427	539	02/13/97
	6,174,816 B1	01/16/01	Yin et al	438	705	04/06/00
	US 2001/ 0011725 A1	08/09/01	Sakama et al	257	59	01/30/01
	6,285,042 B1	09/04/01	Ohtani et al	257	66	09/12/97
	6,291,363 B1	09/18/01	Yin et al	438	769	03/01/99
	6,323,528 B1	11/27/01	Yamazaki et al	257	411	07/29/98
	6,335,541 B1	01/01/02	Ohtani et al	257	59	04/15/96
	6,348,420 B1	02/19/02	Raaijmakers et al	438	769	12/23/99
	6,573,195 B1	06/03/03	Yamazaki et al	438	783	01/24/00

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE

OTHER PRIOR ART - NON-PATENT LITERATURE DOCUMENTS (Including Author, Title, Date, Pertinent Pages)

	1) RABILLER, P. et al, "Electrical Properties of PECVD SiO ₂ N ₂ -H Prepared by Microwave Plasma," Conference Record of the 1988 IEEE International Symposium on Electrical Insulation, IEEE, pp. 149-152 (1988). 2) KAPOOR, V.J., "Review of Thin Oxynitride Dielectrics for Memory Device Technology," Journal of the Electrochemical Society, vo. 138, no. 3, pp. 657-666 (1991).
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EXAMINER:	DATE CONSIDERED:
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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.